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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **Tadashi WATANABE et al.**

Group Art Unit: **2818**

Application Number: **10/823,729**

Examiner: **David Vu**

Filed: **April 14, 2004**

Confirmation Number: **5344**

For: **SEMICONDUCTOR DEVICE FABRICATION METHOD**

Attorney Docket Number: **042341**

Customer Number: **38834**

**AMENDMENT UNDER 37 C.F.R. §1.111**

**MAIL STOP Amendment**

Commissioner for Patents

P. O. Box 1450

Alexandria, VA 22313-1450

November 2, 2006

Sir:

In response to the Office Action dated August 7, 2006, Applicants amend the claims as follows and submit the following remarks.

**Amendments** to the Claims begin on page **2** of this paper.

**Remarks/Arguments** begin on page **13** of this paper.